

SUBCLASS
CLASSIFICATION

UNITED STATES PATENT APPLICATION

APPLICATION NO. 09/817270	CONT/PRIOR F	CLASS 430 250	SUBCLASS 422 296	ART UNIT 1756 2881	EXAMINER Johnston YOUNG
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TITLE
APPLICANTS

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Exposure pattern data generation apparatus associated with standard cell library and charged beam exposure

PTO-2040
12/99

(FACE)